

• Advanced Surface Engineering • Applied Surface Science • Electronic Materials & Processing • Thin Films •

Nanometer-Scale Science & Technology • Plasma Science & Technology

Biomaterial Interfaces • Surface Science • Vacuum Technology

NCCA VS 28th Annual Vacuum Equipment Exhibition

VACUUM TECHNOLOGY • THIN FILMS • PLASMA SCIENCE & TECHNOLOGY • SURFACE SCIENCE

Free Show Admission!

WEDNESDAY, MARCH 21, 2007 • SAN JOSE, CA

WYNDHAM SAN JOSE • 1350 N. FIRST ST. • SAN JOSE, CA 95112



• Magnetic Interfaces & Nanostructures • MEMS and NEMS • Manufacturing Science & Technology •



Northern California
Chapter AVS
110 Yellowstone Dr., Suite 120
Chico, CA 95973

FREE EXHIBIT ATTENDANCE - This will be an excellent opportunity to see a variety of vacuum and surface science related products and learn about services offered by participating companies.

The 28th Annual NCCAVS Vacuum Equipment Exhibition is open free of charge, and everyone with an interest in keeping abreast of the current innovations in our industry is welcome and encouraged to attend. Exhibits will be relevant to engineers, technicians, scientists, and purchasing professionals.

Complimentary Buffet Lunch - Noon to 1p.m.
Complimentary Cocktails & Hors d'oeuvres - 5p.m. Attendees will receive a complimentary drink ticket at the door.

Exhibit Location - Wyndham San Jose,
1350 N. First Street, San Jose, CA 95112
Exhibit Hours - Wednesday, March 21, 2007,
Noon to 7p.m.

Exhibit Information - (408) 350-4364
Website: www.nccavs.org

Participating Companies

(As of 1/8/07)

A&N Corporation
Accu-Glass Products
Advanced Energy
AGS Plasma Systems
Alcatel Vacuum Products
Altair Technologies
Altas Technologies
Ametek/Dycor
Anatech USA
Angstrom Sciences
Avtec
BOC Edwards
Brooks Automation
BrushWellman
Electrofusion Products
CeramTec North America
CHA Industries
Clean Sciences Technology
Denton Vacuum
Dry Plasma Systems
Duniway Stockroom
Ebara Technologies

Emerson Process Management, Brooks Instrument
Evans Analytical Group
Exxus
Fil-Tech West
FMG Enterprises
Fountainhead Technology
Gamma Vacuum
Hidden Analytical
HIS Vacuum Components
Huettinger Electronic
Huntington Labs
ILMVAC
INFICON
InstruTech
Intelligent Micro Patterning
Jori Resources
Kashiyama USA
Key High Vacuum Products
Kurt J. Lesker
Larson Electronic Glass
Materials Science
Mbar

MDC Vacuum Products/
Insulator Seal
MeiVac
MKS Instruments
MPF Products
Nor-Cal Products
Oerlikon Leybold Vacuum USA
Omley Industries
Osaka Vacuum USA
Pfeiffer Vacuum
Plasma Process Group
Plasmaterials
Power Connection
Process Materials
R.D. Mathis
RF VII
SCM High Purity Materials
Semicore Equipment
Seren IPS
Shimadzu Precision Instruments
Sigma Instruments
SSI Inc.

Sumitomo (SHI)
Cryogenics of America
Synergy Vacuum
Televac
Temescal
TGM
Thermal Conductive Bonding
Thermionics Vacuum Products
TMPI
Toho Technology
Transfer Engineering and Manufacturing
U-C Components
Vacuabond
Vacuum Engineering and Materials
Vacuum Parts Supply
Vacuum Research
Valqua America
VAT
Veeco
VG Scienta
VIC Leak Detection
XEI Scientific